



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

For: POLISHING APPARATUS AND  
METHOD FOR FORMING AN  
INTEGRATED CIRCUIT

Art Unit: 3723

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TECHNOLOGY CENTER R3700

In response to the Office Action mailed October 3, 2003, Applicants respectfully request reconsideration of the above referenced patent application. Please consider the following remarks for allowance of the above identified patent application.